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Docket No.: 49677-091

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

: **RESPONSE UNDER 37 CFR 1.116**
EXPEDITED PROCEDURE

In re Application of

Shinichi YAMAGATA, et al.

Serial No.: 09/925,427

Filed: August 10, 2001

: Customer Number: 20277

: Confirmation Number: 5385

: Group Art Unit: 1742

: Examiner: Jenkins, Daniel J.

For: SUBSTRATE MATERIAL FOR MOUNTING A SEMICONDUCTOR DEVICE,
SUBSTRATE FOR MOUNTING A SEMICONDUCTOR DEVICE,
SEMICONDUCTOR DEVICE, AND METHOD OF PRODUCING THE SAME

OK TO
ENTER
ETJ 4/11/04

AMENDMENT UNDER 37 CFR 1.116

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Further to the Office Action dated December 16, 2003, the Advisory Action dated April 6, 2006 and the Supplemental Advisory Action dated April 14, 2004, reconsideration in light of the following remarks and amendments is respectfully solicited.

Certification of Facsimile Transmission

I hereby certify that this paper is being facsimile-transmitted to the Patent and Trademark Office on the date shown below.

David M. Leibert

Type or print name of person signing certification
David M. Leibert 4-16-04
Signature Date